<u>Af Imaging System Method to Determine Optical properties of Thin Film Magnetic</u> <u>Material</u>

Publons ID	(not set)
Wos ID	WOS:000598554800029
Doi	10.1063/1.5141642
Title	4f Imaging System Method to Determine Optical properties of Thin Film Magnetic Material
First Author	
Last Author	
Authors	Franata, N; Sari, FP; Hakim, L; Sudarmaji, A; Handoyo; Handoko, D;
Publish Date	2019
Journal Name	INTERNATIONAL CONFERENCE ON SCIENCE AND APPLIED SCIENCE (ICSAS) 2019
Citation	1
Abstract	In recent years, X-ray has been attracting enormous attention as a tool to determine the magnetic properties of thin film material. We have constructed a simple method base on 4F imaging system to determine analytically optical properties of thin film material. Very small narrow slit is applied to yield diffraction and interference pattern in the X-ray scale. It was found that the sequential changes of Fraunhofer diffraction pattern due to slit width variation. Sensitivity of the method was validated by measuring the power distribution of the temporal observed patterns. The object shape was also varied for comprehensive discussion.
Publish Type	Book in series
Publish Year	2019
Page Begin	(not set)
Page End	(not set)
lssn	0094-243X
Eissn	
Url	https://www.webofscience.com/wos/woscc/full-record/WOS:000598554800029
Author	ARIEF SUDARMAJI